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PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

INVENTOR: Glenn A. Biery et al. )

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SERIAL NO.: 10/605,260 )

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DATE: June 10, 2005

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FOR: **TWO-MASK PROCESS FOR METAL-INSULATOR-METAL CAPACITORS AND  
SINGLE MASK PROCESS FOR THIN FILM RESISTORS**

**CHANGE OF CORRESPONDENCE ADDRESS FOR ALL PURPOSES**

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Dear Sir:

Pursuant to 37 CFR §1.33, please change the correspondence address, (Customer No. 32074), for all purposes for the above identified patent application and resulting patent to:

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Respectfully submitted,

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